	Attorney Docket Number	0047-01400
PATRICATION DISCLOSURE STATEMENT	Application Number	10/002,779
	Filing Date	October 29, 2001
	First Named Inventor	Agarwal et al.
(JAH 2 6 2004 E)	Art Unit	2818
	Examiner Name	David Vu

U.S. PATENT DOCUMENTS

Examiner's Initials*	Cite No. (optional)	Number	Date	Name
DV		5,893,731	4/13/99	Lee et al.
ÞV		6,309,713	10/30/01	Mak et al.
DV		6,635,523	10/21/03	Uchiyama et al.
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EXAMINER SIGNATURE:	fihuland	DATE CONSIDERED:	07/18/04

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					ey Docket Number	6047-61466
,			Applic	ation Number	10/002,779	
INEOR	MATIO		EMENT	Filing Date		October 29, 2001
INFORMATION DISCLOSURE STATEMENT O P E BY APPLICANT Filing Date First Named Inventor		lamed Inventor	Agarwal et al.			
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DV		5,834,357	11/10/98		Kang	
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